



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Jun HATAKEYAMA

Serial No.: 10/003,288

Filed: December 6, 2001

Title: AMINE COMPOUNDS, RESIST COMPOSITIONS AND PATTERNING PROCESS

Group Art Unit.: 1752

Examiner: LEE, Sin J.

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TC 1700

REPLY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed on September 10, 2003, please amend the claims as follows and consider the remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 16 of this paper.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Services as First Class Mail in an envelope addressed to: Commissioner of Patents, P O Box 1450, Alexandria, VA 22313-1450 on: December 19, 2003
Name: Jun Hatakeyama

Signature: [Signature]

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01 FC:1201 86.00 OP
02 FC:1202 180.00 OP